

# **Notice of References Cited**

Application/Control No.  
10/052,396

Applicant(s)/Patent Under  
Reexamination  
PERRIN ET AL.

Examiner  
William C. Choi

Art Unit  
2873

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*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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K	US-			
L	US-			
M	US-			

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## **NON-PATENT DOCUMENTS**

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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